Atty Docket No.:

278506US0



11-08-2005 103115751



FORM PTO-1595 06-04

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A. Patent Application No.(s) 11/226,361	B. Patent No.(s)
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In consideration of value received, I, having a residence as stated below above my name, the sole inventor (if only one name is listed below) or a joint inventor (if plural inventors are listed below) of an invention described in an application for United States patent entitled:

OXIDE SUPERCONDUCTOR AND METHOD OF PREPARING THE SAME

sell and assign to

- 1. KABUSHIKI KAISHA TOSHIBA, a Japanese corporation, having a business address at 1-1, Shibaura 1-chome, Minato-ku, Tokyo 105-8001, Japan; and
- 2. International Superconductivity Technology Center, the juridical foundation, having a business address at Eishin Kaihatsu BLDG. 6F, 5-34-3, Shinbashi, Minato-ku, Tokyo 105-0004 Japan

its successors, assigns or nominees, hereinafter referred to as "Assignee", my entire right, title and interest in and to said invention as disclosed, shown and described in said United States patent application:

(check one)	[X]	executed concurrently herewith		
	[]	executed on September 9, 2005,	September 12, 2005, September 1	2, 2005
		Application No. 11/226, 361	filed September 15,2005	,

and in and to all applications for patent and patents for invention including all divisions, reissues, continuations, substitutes and extensions thereof and all rights arising under or pursuant to any and all international agreements, treaties or laws relating to the protection of industrial property, including rights of priority, resulting from the filing of any of said applications; and I authorize and request any official whose duty is to issue patents, to issue any patent on said invention or resulting therefrom to said Assignee, and I agree that on request and without further consideration, but at the expense of said Assignee, I will communicate to said Assignee or its representatives all facts known to me respecting said invention and testify in any legal proceedings, sign all lawful papers, execute all divisional, continuing, continued prosecution, reissue, or other applications, make all rightful oaths and declarations, and generally do everything possible to aid said Assignee to obtain and enforce proper patent protection for said invention.

I hereby grant the following law firm the power to insert on this Assignment any further identification which may be necessary or desirable in order to comply with the Rules of the U.S. Patent and Trademark Office for recordation of this document.

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